

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/659,369	YANAGAWA ET AL.
	Examiner	Art Unit
	Mike Qi	2871

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
349	141 146	US-PGPUB 1/4/66	SEL
	146 139		
	112 153		